May 2000

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Cheng, Ruihua; Borca, C.N.; and Dowben, Peter A., "SELECTIVE AREA CHEMICAL VAPOR DEPOSITION OF CHROMIUM OXIDES" (2000). Peter Dowben Publications. 166.
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SELECTIVE AREA CHEMICAL VAPOR DEPOSITION OF CHROMIUM OXIDES

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ABSTRACT

We demonstrate that two-phase CrO₂ and Cr₂O₃ thin films can be grown by using selective organometallic chemical vapor deposition through the oxidation of Cr(CO)₆ in an oxygen environment. While the magnetization measurements show that both chromium oxides are present, the relative weight of each phase depends on the oxygen partial pressure. Changes of the Curie temperature, Tₐₐ, and the saturation magnetization field may be possible by controlling the stoichiometry.

INTRODUCTION

Chromium oxides have been seriously considered as spin-polarized electron injectors to spin-tunnel junctions [1] and other magnetoresistive devices [2,3]. The insulating antiferromagnetic chromium oxide Cr₂O₃ has a Neél temperature of 307K and is suitable as a tunnel junction barrier [3] both below and above the Neél temperature. The ferromagnetic chromium oxide CrO₂ with Tₐ of 397k [4], has been predicted half-metallic (metallic for one spin direction while insulating for the other spin direction) by band structure calculations [5-9], though Kulatov and Mazin found CrO₂ to be insulating in both spin directions [10]. Evidence of nearly 100% polarization, consistent with the half metallic character of CrO₂, were observed in spin-polarized photoemission [11], vacuum tunneling [12], and Andreev scattering [13], though some discrepancies from perfect half metallic character remain unresolved. The high electron polarization, in addition to the half metallic character of the surface [9] (and by extension, one hopes the interface as well) makes CrO₂ an attractive material for spin-polarized electron tunneling, and very large tunneling magnetoresistance (TMR) is expected.

It is difficult to fabricate CrO₂ films using conventional methods because CrO₂ is metastable. This is not altogether bad, as the two-phase CrO₂/Cr₂O₃ system exhibits higher magnetoresistance than the pure material [3]. The oxidation of the organometallic complex hexacarbonyl Cr(CO)₆ has the potential for selective deposition of CrO₂ [14-17]. These studies have established that chromium oxides are the thermodynamic sinks of chromium hexacarbonyl decomposition [16], and the oxidation is further aided by the presence of an ambient oxygen background [14,15]. By modifying this organometallic chemical vapor deposition (OMCVD) procedure, we have been able to fabricate the ferromagnetic and antiferromagnetic chromium oxides. Here we describe both the growth and the magnetic properties of these films.

EXPERIMENTAL APPROACH

Film growth was carried out on Si (111) substrates in an ultra high vacuum chamber with maintained base pressure of 1.0⁻⁹ Torr. This chamber was designed for laser-initiated chemical vapor deposition, as described elsewhere [18-19]. The prevalent source compound was Cr(CO)₆.
During the deposition the photolytic decomposition of Cr(CO)₆ was performed by a commercial nitrogen laser with the main emission line at 337 nm (corresponding to 3.69 eV) and running at a repetition rate of 10 Hz. A quartz lens was used to focus the radiation onto the substrate.

The laser-initiated decomposition and oxidation was aided by the ambient oxygen (O₂) atmosphere ranging from 2x10⁻⁷ to 1x10⁻⁶ Torr, relative to the Cr(CO)₆ partial pressure of 1x10⁻⁵ Torr. Purity of the gases introduced was monitored with a quadruple mass spectrometer operated in pulse counting mode.

The films were examined by scanning electron microscopy (SEM) and x-ray emission spectroscopy (XES or EDAX). Magnetic measurements have been carried out by using a superconducting quantum interference device (SQUID) magnetometer.

RESULTS

Figure 1 shows the SEM image of the film fabricated with 1x10⁻⁶ Torr O₂ partial pressure and 1x10⁻⁵ Torr Cr(CO)₆ partial pressure. The topology of the film is relatively uniform, with only a fine microstructure visible on an 800 nm scale.

Figure 1: The scanning electron microscope image of a chromium oxide film fabricated on a Si (111) substrate by laser-initiated decomposition of Cr(CO)₆ (pressure 1x10⁻⁵ Torr) in an ambient O₂ (1x10⁻⁶ Torr) background.
As seen in Figure 2, the EDAX spectra of the same film shown in Figure 1, provides evidence for the desirable oxygen and chromium signal in addition to the strong Si signal from the substrate.

Figure 2 shows the magnetization versus temperature obtained from SQUID. The critical temperature clearly depends upon the oxygen partial pressure at the time of film fabrication. At low oxygen partial pressure (an O₂ pressure of 2x10⁻⁷ Torr relative to the Cr(CO)₆ partial pressure of 1x10⁻⁵ Torr) the Curie temperature was 345±10 K. At higher oxygen partial pressure (an O₂ pressure of 1x10⁻⁶ Torr relative to the Cr(CO)₆ partial pressure of 1x10⁻⁵ Torr) the Curie temperature was 390±10 K.

The hysteresis loop, shown in the inset to Figure 3, was obtained at 100 K with the applied magnetic field in the plane of the film. The curve shown is for the sample with the lower O₂ partial pressure (an O₂ pressure of 2x10⁻⁷ Torr relative to the Cr(CO)₆ partial pressure of 1x10⁻⁵ Torr). We find that the saturation field for this film is about 1.5 T.

**DISCUSSION**

The absence of a sharp Tₛ and the presence of a long tail in the magnetization curves (Figure 3) near the critical temperature, are suggestive of a two-phase system. This is supported by indications of both ferromagnetic and antiferromagnetic behavior in the hysteresis loops.

The fact that the coercive fields for these films are often not symmetric in our films suggests uniaxial antiferromagnetism, in addition to the more conventional antiferromagnetic behavior. In the hysteresis loop obtained for the film at the lower oxygen partial pressure, for the left half of the loop the coercivity is 250 Oe while for the right half of the loop the coercivity is 150 Oe, in addition to having other characteristics of antiferromagnetism: strong hysteresis at higher fields.
Figure 3: The magnetization ($M/M_0$) versus temperature ($T$) at an applied field of $H=500$ Oe. Data are shown for two films: at low oxygen partial pressure ($\Delta$), i.e. (an $O_2$ pressure of $2\times10^{-7}$ Torr relative to the $Cr(CO)_6$ partial pressure of $1\times10^{-5}$ Torr) and at higher oxygen partial pressure (■), i.e. (an $O_2$ pressure of $1\times10^{-6}$ Torr relative to the $Cr(CO)_6$ partial pressure of $1\times10^{-5}$ Torr). The hysteresis loop, shown as an inset, was taken at 100K for the film with an $O_2$ pressure of $2\times10^{-7}$ Torr.

We believe that our films contain both ferromagnetic $CrO_2$ and antiferromagnetic $Cr_2O_3$ phases. At lower oxygen partial pressures, $CrO_2$ becomes less dominant, compared with $Cr_2O_3$, and the Curie temperature is suppressed to lower temperatures than the expected 397 K of $CrO_2$ (the Neél temperature of $Cr_2O_3$ is 307 K). When we increased the $O_2$ partial pressure, the amount of $CrO_2$ phase increased, and the critical temperature approached the expected $T_c$ of 397 K.

In any case, deposition of our two-phase chromium oxide films is restricted to the area of the substrate illuminated with the light, so that the process is clearly a selective area deposition process.
CONCLUSIONS

We have used laser-assisted chemical vapor deposition and oxidation of Cr(CO)₆ to make chromium oxide thin films. The advantage of this technique is selective area deposition. The resulting films exhibit behavior consistent with a two-phase system containing both Cr₂O₃ and CrO₂ domains in the films, and the relative weight of each phase appears to depend on the O₂ partial pressure. If we choose the appropriate oxygen partial pressure, we should be able to obtain pure Cr₂O₃ and CrO₂ phases respectively.

ACKNOWLEDGEMENTS

This work was supported by NSF through grant # DMR-98-02126, the Center for Materials Research and Analysis (CMRA) and the Nebraska Research Initiative at the University of Nebraska.

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